

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE-----X
In re application of: Attorney Docket No.
: CHAIX

Applicant: Catherine CHAIX et al

Application No. Unknown (US National Phase :
Of PCT/FR03/01868 :

GAU: Unknown

Filed: June 18, 2003

Filed: Herewith

: Examiner: Unknown

For: "MATERIAL EVAPORATION
CHAMBER WITH DIFFERENTIAL
VACUUM PUMPING"
-----XMAIL STOP PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450PRELIMINARY AMENDMENTSIR:

Prior to calculation of the filing fee, please amend the above application as follows:

IN THE CLAIMS:

Please AMEND the claims to read as set forth in the following listing of claims.

1. (original) An evaporation chamber of materials including a vacuum chamber (10), a first pumping unit (13) to pump said chamber and sources of material, characterised in that:

- a wall (23) liable to provide total or partial vacuum tightness, delineates within the vacuum chamber (10) a first volume (25) pumped by said first pumping unit (13) and a second volume (22) pumped by a second pumping unit (24),